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/ Ruth Montalvo Date: 01/12/05

Customer No. 026418

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Attorney's Docket No.: GK-OEH-191/500814.20093

U.S. Application No.:

International Application No.: PCT/DE2003/002359

International Filing Date: JULY 10, 2003

10 JULY 2003

Priority Date Claimed: JULY 12, 2002

12 JULY 2002

Title of Invention:

PULSE LASER ARRANGEMENT AND METHOD FOR SETTING PULSE LENGTH FOR LASER PULSES

Applicant(s) for (DO/EO/US): Guenter HOLLEMANN, Martin LEITNER and Jan SYMANOWSKI

Mail Stop PCT
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-450

INFORMATION DISCLOSURE STATEMENT

S I R:

Applicant herewith submits together with the simultaneously filed National Phase application of PCT/DE2003/002359, a copy of the International Search Report (PCT/ISA/210) dated December 3, 2004, citing some of the following references:

	Document Number	Date	Name and/or Country	English Translation
AA	4,725,787	02/16/1998	Chandra	
AB	4,896,119	01/23/1990	Williamson, et al.	
AC	5,867,324	02/02/1999	Kmetec, et al.	
AD	5,907,570	05/25/1999	Nighan, et al.	
AE	6,122,097	09/19/2000	Weston, et al.	
AL	1 308 384	02/28/1973	Great Britain	
AM	0 609 978	08/10/1994	European	
AN	WO 96/16484	05/30/1996	WIPO	
AO	199 27 918	12/21/2000	Germany	Abstract only
AP	199 58 566	06/07/2001	Germany	Abstract only
AQ	2 357 369	06/20/2001	Great Britain	
AR	100 43 269	04/04/2002	Germany	Abstract only
AS	100 63 976	07/04/2002	Germany	Abstract only

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AX R. Iffländer, Solid state Lasers for Materials Processing, Springer Series in Optical Sciences, Springer Verlag, Berlin (2001)

Accompanying this Information Disclosure Statement and form PTO-1449 are copies of the first page of each document listed including four (4) English Abstracts except article. Documents AO and AP are mentioned on pages 2 and 7 of the substitute specification.

This submission is not an admission that the information disclosed in the documents is material to the patentability of the invention disclosed and/or claimed in the above-identified application.

Respectfully submitted,


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Enclosures:

Search Reports (PCT/ISA/210);
PTO-1449;
1st pages of 13 listed documents
4 English Abstracts

LIST OF PRIOR ART CITED BY APPLICANT
(Filed on January 12, 2005)

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Docket No. GK-OEH-191/500814.20093

Applicant(s): Guenter HOLLEMANN, Martin LEITNER and Jan SYMANOWSKI

Application No. (Int'l Appln No. PCT/DE2003/002359 10JUL03) Group:

Filed: Examiner:

U.S. PATENT DOCUMENTS

Exam. Init		Document Number	Date	Name	Class	Sub-Class	Filing Date Appropriate
	AA	4,725,787	02/16/1998	Chandra			
	AB	4,896,119	01/23/1990	Williamson, et al.			
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	AF						
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FOREIGN PATENT DOCUMENTS

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	AL	1 308 384	02/28/1973	Great Britain			
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	AX	R. Iffländer, Solid state Lasers for Materials Processing, Springer Series in Optical Sciences, Springer Verlag, Berlin (2001)
	AY	
	AZ	

Examiner:

Date:

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.